

# Claims

[c1]

1.A method for performing an electromigration check for conductors with alternating current flow adjacent to conductors with direct current flow in an integrated circuit comprising:

determining resistances  $R_{\text{WIRE}}$  and a capacitance matrix  $C$  for the integrated circuit;

converting the capacitance matrix  $C$  into a thermal conductance matrix  $G$ ;

determining temperature differences  $\Delta T_{ni}$  between conductors from thermal conductances  $G_{thi}$  of the thermal conductance matrix  $G$ ;

approximating power flow  $P_n$  into conductors with direct current flow due to adjacent conductors with alternating current flow in the integrated circuit from the temperature differences  $\Delta T_{ni}$  between conductors and the thermal conductances  $G_{thi}$ ;

determining a power limit as a function of the maximum temperature difference  $\Delta T_{\text{MAX}}$  that ensures reliability of the integrated circuit; and

performing the electromigration check by limiting power generated in the conductors with alternating current flow to less than the power limit,

wherein  $n$ ,  $ni$  and  $thi$  are numerical subscripts that identify parameters as associated with conductor  $n$ , conductor  $n$  and conductor  $i$ , and a thermal characteristic of conductor  $i$ , respectively.

[c2]

2.The method of claim 1, wherein the thermal conductance matrix  $G$  is determined from the product of the capacitance matrix  $C$  and a scalar factor  $F$  and the scalar factor is given by a ratio of thermal conductivity  $\kappa$  to permittivity  $\epsilon$ .

[c3]

3.The method of claim 1 , wherein the power limit is given by the product of scalar factor  $F$ , the total capacitance  $C_{ntot}$  and the maximum temperature difference  $\Delta T_{MAX}$ .

[c4]

4.The method of claim 1 , wherein the  $I_{RMS}$  value is determined by the expression:

$C_{load} * V_{dd} * frequency * Switching \text{ factor}.$

[c5]

5.The method of claim 1 , wherein the thermal conductances  $G_{thi}$  are inputs for a circuit simulator that determines temperature differences between conductors  $\Delta T_{ni}$  as outputs of the circuit simulator.

[c6]

6.The method of claim 1 , wherein the capacitance matrix  $C$  and resistances  $R_{WIRE}$  are determined by using simulation and analysis tools that include capacitance/resistance extraction capabilities.

[c7]

7.A method for performing an electromigration check for conductors with alternating current flow adjacent to conductors with direct current flow comprising:

determining resistances  $R_{WIRE}$  and capacitances  $C_{ni}$  for conductors with alternating current flow and conductors with direct current flow;

converting the capacitances  $C_{ni}$  into thermal conductances  $G_{thi}$ ;

determining temperature differences  $\Delta T_{ni}$  between conductors from the thermal conductances  $G_{thi}$ ;

approximating power flow  $P_n$  into conductors with direct current flow due to adjacent conductors with alternating current flow from the temperature differences  $\Delta T_{ni}$  between conductors and thermal conductances  $G_{thi}$ ;

determining a power limit as a function of a maximum temperature difference  $\Delta T_{MAX}$  for the conductors that ensures reliability of the conductor; and

performing the electromigration check by limiting power generated in the conductors with alternating current flow to less than the power limit,  
wherein  $n$ ,  $n_i$  and  $t_{hi}$  are numerical subscripts that identify parameters as associated with conductor  $n$ , conductor  $n$  and conductor  $i$ , and a thermal characteristic of conductor  $i$ , respectively.

[c8]

8.The method of claim 7, wherein the thermal conductances  $G_{thi}$  are determined from the product of the capacitances  $C_{ni}$  and a factor  $F$  and scalar factor  $F$  is given by a ratio of thermal conductivity  $\kappa$  to permittivity  $\epsilon$ .

[c9]

9.The method of claim 7, wherein the power limit is given by the product of scalar factor  $F$ , the total capacitance  $C_{ntot}$  and the maximum temperature difference  $\Delta T_{MAX}$ .

[c10]

10.The method of claim 7, wherein the  $I_{RMS}$  value is determined by the expression:

$C_{load} * V_{dd} * \text{frequency} * \text{Switching factor}$ .

[c11]

11.The method of claim 7, wherein the thermal conductances  $G_{thi}$  are inputs for a circuit simulator that determines temperature differences between conductors  $\Delta T_{ni}$  as outputs of the circuit simulator.

[c12]

12.The method of claim 7, wherein the capacitances  $C_{ni}$  and resistances  $R_{WIRE}$  are determined by using simulation and analysis tools that at least include capacitance/resistance extraction capabilities.

[c13]

13.A method for performing a check of local heating in a device comprising:

determining resistances  $R_{WIRE}$  and at least one of capacitances  $C_{ni}$  and a capacitance matrix  $C$  for the device;

determining thermal conductances  $G_{thi}$  from the at least one of capacitances  $C_{ni}$  and a capacitance matrix  $C$ ;

setting a maximum temperature difference  $\Delta T_{MAX}$  in accordance with electromigration requirements; determining a power limit  $F * C_{ntot} * \Delta T_{MAX}$  as a function of the maximum temperature difference  $\Delta T_{MAX}$ ;

checking each interconnect conductor with an alternating current flow to determine if power generated  $I_{RMS} * R_{WIRE}^2$  is less than the power limit  $F * C_{ntot} * \Delta T_{MAX}$ ;

indicating no local heating problem with an interconnect conductor when power generated  $I_{RMS} * R_{WIRE}^2$  is less than the power limit  $F * C_{ntot} * \Delta T_{MAX}$ ;

indicating a local heating problem exist with said interconnect conductor when the power generated  $I_{RMS} * R_{WIRE}^2$  is equal to or greater than power limit  $F * C_{ntot} * \Delta T_{MAX}$  and taking corrective action to reduce the power generated  $I_{RMS} * R_{WIRE}^2$ ; and

continuing to check each interconnect conductor with alternating current flow until all interconnect conductors have a value for power generated  $I_{RMS} * R_{WIRE}^2$  less than the power limit  $F * C_{ntot} * \Delta T_{MAX}$ ,

wherein  $n$ ,  $n_i$  and  $th_i$  are numerical subscripts that identify parameters as associated with conductor  $n$ , conductor  $n$  and conductor  $i$ , and a thermal characteristic of conductor  $i$ , respectively,  $F$  is a scalar factor, and  $ntot$  is a numerical subscript identifying a total value of an associated parameter.

[c14]

14.The method of claim 13, wherein the thermal conductances  $G_{th_i}$  are determined from the product of the capacitances  $C_{n_i}$  and a factor  $F$  and scalar factor  $F$  is given by a ratio of thermal conductivity  $\kappa$  to permittivity  $\epsilon$ .

[c15]

15.The method of claim 13, wherein the power limit is given by the product of scalar factor  $F$ , the total capacitance  $C_{ntot}$  and the maximum temperature difference  $\Delta T_{MAX}$ .

[c16]

16.The method of claim 13, wherein the  $I_{RMS}$  value is determined by the expression:

$C_{load} * V_{dd} * \text{frequency} * \text{Switching factor}$ .

[c17]

17.The method of claim 13, wherein said thermal conductances  $G_{thi}$  are inputs for a circuit simulator that determines temperature differences  $\Delta T_{ni}$  as outputs of the circuit simulator.

[c18]

18.The method of claim 13, wherein the capacitances  $C_{ni}$  and resistances  $R_{WIRE}$  are determined by using simulation and analysis tools that include capacitance/resistance extraction capabilities.

[c19]

19.A computer-readable medium having a plurality of computer executable

instructions for causing a computer to perform an electromigration check for conductors with alternating current flow adjacent to conductors with direct current flow in an integrated circuit, the computer executable instructions comprising:

instructions for determining resistances  $R_{WIRE}$  and a capacitance matrix  $C$  for the integrated circuit;

instructions for converting the capacitance matrix  $C$  into a thermal conductance matrix  $G$ ;

instructions for determining temperature differences  $\Delta T_{ni}$  between conductors from thermal conductances  $G_{thi}$  of the thermal conductance matrix  $G$ ;

instructions for approximating power flow  $P_n$  into conductors with direct current flow due to adjacent conductors with alternating current flow in the integrated circuit from the temperature differences  $\Delta T_{ni}$  between conductors and the thermal conductances  $G_{thi}$ ;

instructions for determining a power limit as a function of the maximum temperature difference  $\Delta T_{MAX}$  that ensures reliability of the integrated circuit; and

instructions for performing the electromigration check by limiting power generated in the conductors with alternating current flow to less than the power limit, wherein  $n$ ,  $ni$  and  $thi$  are numerical subscripts that identify parameters as associated with conductor  $n$ , conductor  $n$  and conductor  $i$ , and a thermal

characteristic of conductor  $l$ , respectively,  $F$  is a scalar factor, and  $ntot$  is a numerical subscript identifying a total value of an associated parameter.

[c20]

20.The computer readable medium of claim 19, wherein the thermal conductance matrix  $G$  is determined from the product of the capacitance matrix  $C$  and a scalar factor  $F$  and the scalar factor is given by a ratio of thermal conductivity  $\kappa$  to permittivity  $\epsilon$ .

[c21]

21.The computer readable medium of claim 19, wherein the power limit is given by the product of scalar factor  $F$ , the total capacitance  $C_{ntot}$  and the maximum temperature difference  $\Delta T_{MAX}$ .

[c22]

22.The computer readable medium of claim 19, wherein the  $I_{RMS}$  value is determined by the expression:

$C_{load} * V_{dd} * \text{frequency} * \text{Switching factor}.$

[c23]

23.The computer readable medium of claim 19, wherein the thermal conductances  $G_{thi}$  are inputs for a circuit simulator that determines temperature differences between conductors  $\Delta T_{ni}$  as outputs of the circuit simulator.